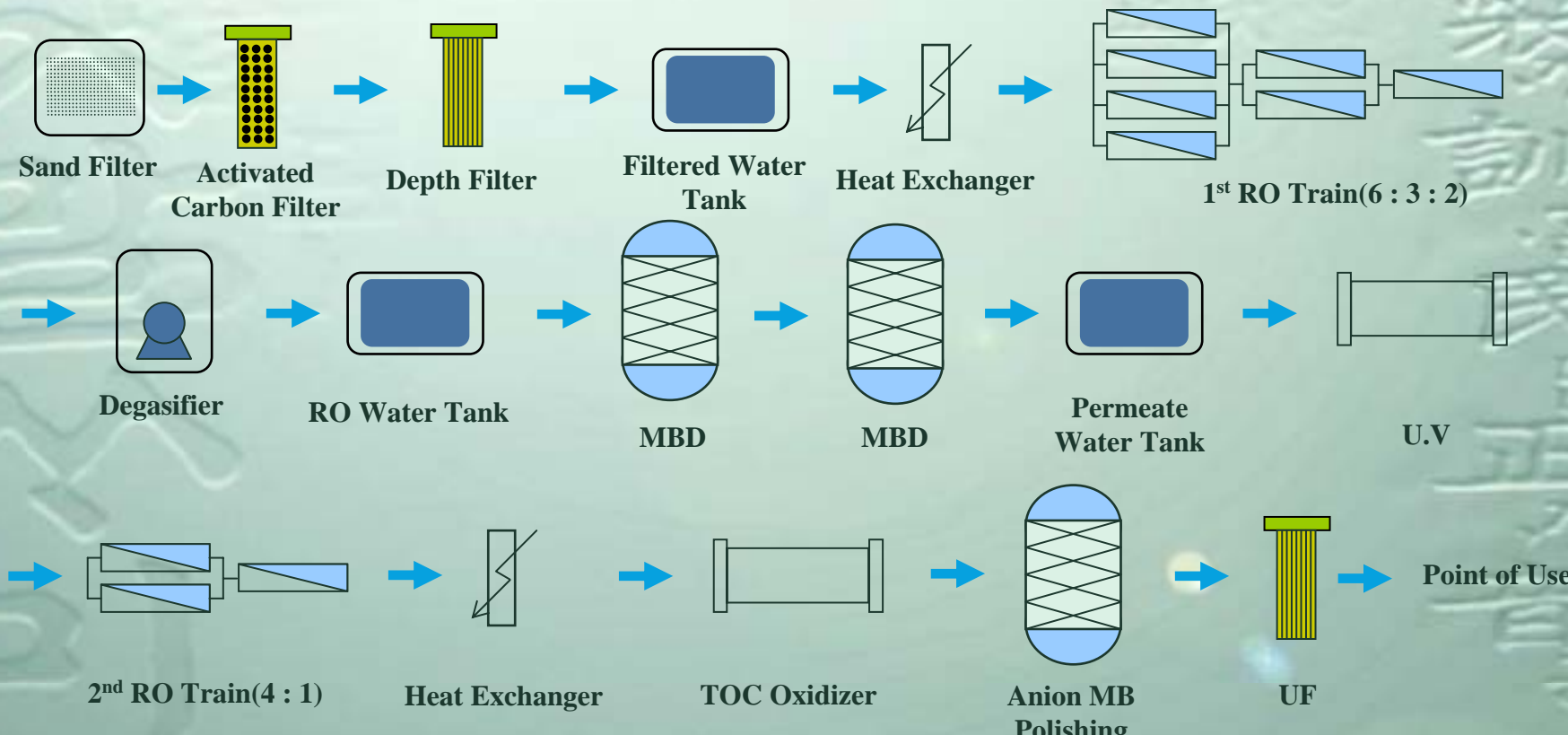


LG Siltron

- ❖ Ultra Pure Water for Wafer rinsing
- ❖ Bumhan Engineering(韓)

❖ Lay out of Equipment



Details of CSM Installation

Operating Duration

❖ '99.

CSM Model

❖ RE8040-BE / 412pcs

Capacity of Equip.

❖ 5,000m³/day
(calculated by 1st RO)

RO Array

❖ 1st RO 6 : 3 : 2 (2set)
❖ 2nd RO 4 : 1 (2set)

Feed Water

❖ Pretreated Industrial
Water

Remarks

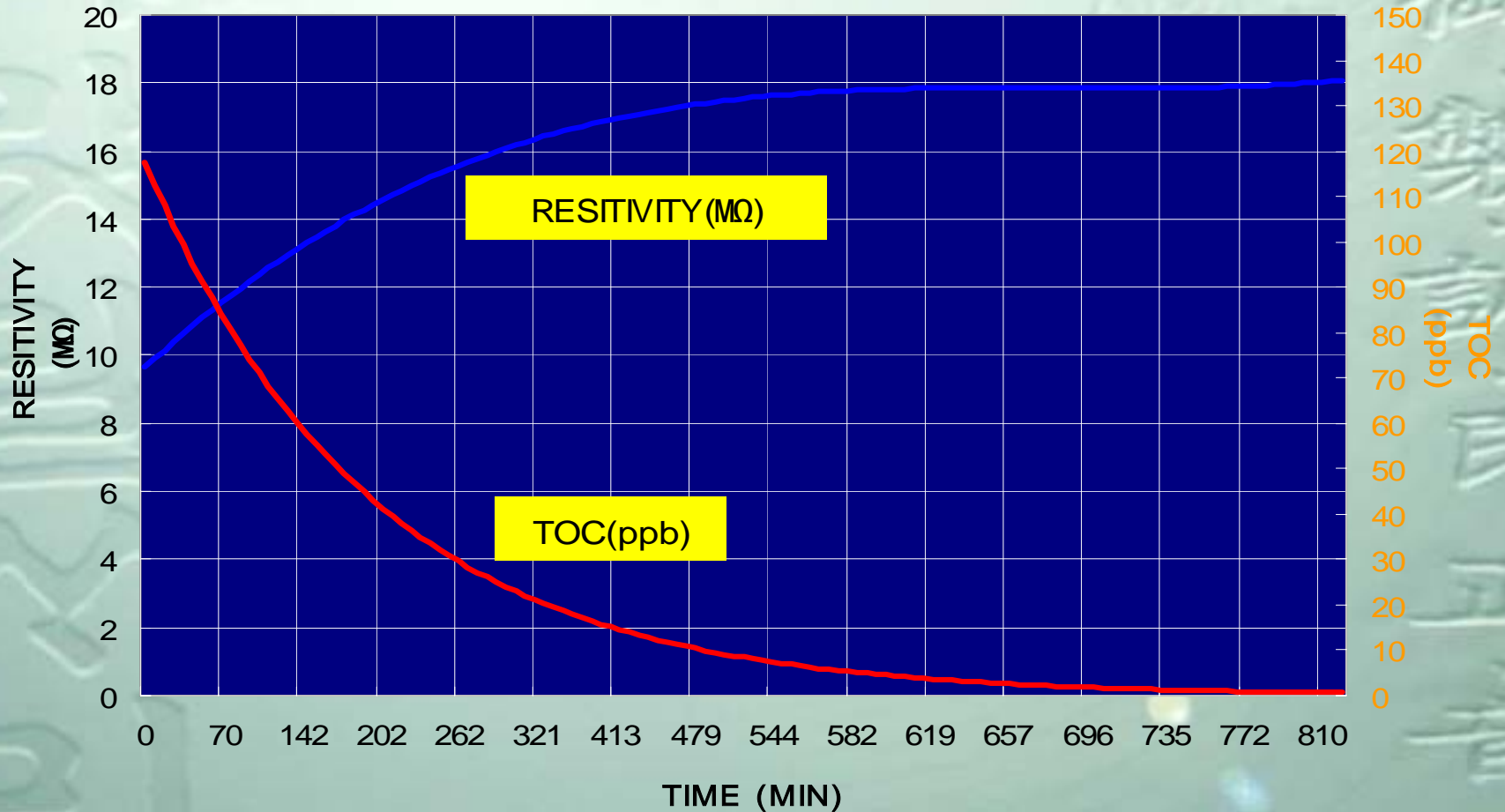
❖ CIP : 1time/3months

Permeate Quality

❖ Conductivity 18.2M Ω
❖ TOC 5ppb

Initial Operating Data

❖ Rinse Down Time



Related Photos

